

<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b> ( Not for submission under 37 CFR 1.99)	Application Number		10596249
	Filing Date		2006-06-06
	First Named Inventor	Buehrer, et al.	
	Art Unit	2812	
	Examiner Name		
	Attorney Docket Number	FIS920030120US1	

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